

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of: Demos et al.	Group Art Unit: 2823
Application No: 10/783,748 Confirmation No: 7358	Examiner: Khiem D. Nguyen
Filed: February 20, 2004	Attorney Docket No: 007034 USA P02/DSM/ELK/JP
Title: CLEAN PROCESS FOR AN ELECTRON BEAM SOURCE	December 15, 2006

**AMENDMENT IN RESPONSE TO FINAL OFFICE ACTION**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450.

VIA ELECTRONIC FILING

Dear Sir:

This communication is in response to the Office communication mailed on September 15, 2006, and is timely being filed within three months thereof. If any extension fee and/or claims fee is required, please charge Deposit Account No. 10-0258.

**Certificate of Transmission**

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, sent by facsimile transmitted to the U.S. Patent and Trademark Office at (571) 273-8300, or electronically filed on the date shown below.

By: \_\_\_\_\_

  
Amy Wells

Date: December 15<sup>th</sup>, 2006